



P/1250-255

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
Tatsufumi KUSUDA et al.  
Serial No.: 10/645,067  
Filed: August 21, 2003

New York, New York  
Date: November 13, 2003  
Group Art Unit: Not Yet Assigned  
Examiner: Not Yet Assigned

For: LIGHT IRRADIATION TYPE THERMAL PROCESSING APPARATUS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
Commissioner for Patents P.O. Box 1450,  
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Max Moskowitz

Name of applicant, assignee or  
Registered Representative

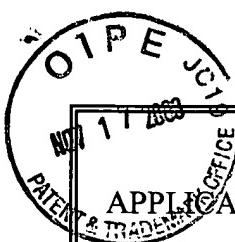
Signature

November 13, 2003  
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Respectfully submitted,

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Enclosures



<b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)	Application 10/645,067		OFGS File No. P/1250-255	
	Applicant Tatsufumi KUSUDA et al.			
	Filing Date August 21, 2003	Group Art Unit		

### U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US- 4,571,486	02/1986	Arai et al.			02/18/1986
	US- 4,649,261	03/1987	Sheets			02/07/1985
	US-					

### FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	2002-110579	04-2002	Japan				X
	2002-110580	04-2002	Japan				X
	2001-237195	08-2001	Japan				X
	57-162340	10-1982	Japan				X
	63-166219	07-1988	Japan				X
	59-169125	09-1984	Japan			X	
	60-258928	12-1985	Japan			X	

### OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	English translation of Abstract for Japanese Patent Application Laid Open No. 2002-110579
	English translation of Abstract for Japanese Patent Application Laid Open No. 2002-110580
	English translation of Abstract for Japanese Patent Application Laid Open No. 2001-237195
	English translation of Abstract for Japanese Patent Application Laid Open No. 57-162340
	English translation of Abstract for Japanese Patent Application Laid Open No. 63-166219
	Japanese Patent Application Laid Open No. 59-169125 which corresponds to U.S. Patent No. 4,571,486 (as listed above)
	Japanese Patent Application Laid Open No. 60-258928 which corresponds to U.S. Patent No. 4,649,261 (as listed above)

Examiner	Date Considered
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	